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October 11, 2005

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 11, 2005.

Gayle W. Chaney

Date of Signature: 10/11/05

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Re: U.S. Patent Application Serial No. 10/801,781 for  
PROCESS FOR PRODUCING AN ETCHING MASK ON A  
MICROSTRUCTURE, IN PARTICULAR A SEMICONDUCTOR  
STRUCTURE WITH TRENCH CAPACITORS, AND  
CORRESPONDING USE OF THE ETCHING MASK  
Our Ref. No. 1406/189

Sir:

Please find enclosed in connection with the subject U.S. patent application the following documents:

1. An Amendment A with Replacement Abstract; and
2. A return-receipt postcard to be returned to us with the U.S. Patent and Trademark Office filing stamp thereon.

The Commissioner is hereby authorized to charge any fees associated with the filing of this correspondence to Deposit Account Number 50-0426.

Respectfully submitted,

JENKINS, WILSON & TAYLOR, P.A.

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REJ/gwc

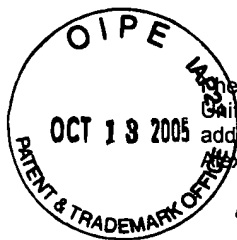
Enclosures

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PATENT

Gayle W. Chaney  
Gayle W. Chaney  
Date of Signature 10/11/05

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Moll et al.

Group Art Unit: 2891

**Serial No.:** 10/801,781

Examiner: Chandra P. Chaudhari

Filed: March 16, 2004

Docket No.: 1406/189

Confirmation No.: 3095

For: PROCESS FOR PRODUCING AN ETCHING MASK ON A MICROSTRUCTURE,  
IN PARTICULAR A SEMICONDUCTOR STRUCTURE WITH TRENCH  
CAPACITORS, AND CORRESPONDING USE OF THE ETCHING MASK

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AMENDMENT A

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is responsive to the Office Action Summary dated September 19, 2005,  
for which a shortened statutory period for reply is set to expire on November 19,  
2005. Favorable consideration is respectfully requested in view of the following  
Amendments and Remarks.